

<b>Notice of References Cited</b>	Application/Control No. 10/743,723	Applicant(s)/Patent Under Reexamination EMBERT ET AL.	
	Examiner Ing-Hour Lin	Art Unit 1725	Page 1 of 1


**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,648,640	11-2003	Rubbert et al.	433/24
	B	US-6,835,066	12-2004	Iiyama et al.	433/223
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	O'Brien et al (Pub. No. US 2002/0013636A1) of application serial number 09/656255 filed 9/6/2000.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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